







Grading and Homework Policy

•	Grading: Midterms (2)	40%
	Homework	20%
	Class participation	15%
	(including scribes)	
	Final Exam	25%
	Project (for GRAD)	25%

- Homework Policy:
 - HW must be turned in on Friday in class on the date due.
 - HW will not be graded if absence without excuse.
 - Work out all problems, arranging your work in a logical and neat manner. (neatness counts!)

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How To Do Well in This Class

- Recognize early that it is different than other courses, survey of materials and properties so change topics frequently nature of the course
- Attend and participate discussions in class
- Finish the reading assignments before the class
- You should expect to spend 8 to 10 hours outside of class per week on homework and projects.

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• Do homeworks and <u>understand</u> them, and exercise similar problems.

Week Lectures 1 (Aug 24-Aug 28) Introduction, Basic Quantum Mechanics 2 (Aug 31- Sep 4) Molecular transport and thermodynamics 3 (Sep 7-Sep 11) **Continuum Solid Mechanics** 4 (Sep 14-Sep 18) Momentum/energy transfer at Nanoscale 5 (Sep 21-Sep 25) Surface and Interface I/1st Midterm 6 (Sep 28-Oct 2) Adhesion, surface tension, lubrication 7 (Oct 5-Oct 9) Collective phenomena, self assembly 8 (Oct 12-Oct 16) **Project proposal** 9 (Oct 19-Oct 23) Nanophase materials 10 (Oct 26-Oct 30) Thermal and Fluidic Aspects in Nanodevices 11 (Nov 2-Nov 6) Sensing and Actuation in Nanoscale Nanoscale Energy conversion / 2nd Midterm 12 (Nov 9-Nov 13) 13 (Nov 16-Nov 20) Nanomanufacturing 14 (Nov 23- Nov 27) **Thanksgiving Break** 15 (Nov 30-Dec 4) Summary, Final presentation Mech





Incomplete list of Nanocourses At UIUC

ME/ECE 485 Introduction to Microelectromechanical Devices and Systems ME 498 Theory, Fabrication and Characterization of MEMS ME 498 Modeling and Simulation of MEMS ME 498: Introduction of Biology for Engineers ECE 498 Introduction to Nanotechnology TAM 524 Micromechanics of Materials CHBE 553 Surface Chemistry **MSE 582 Surface Physics** ECE 583 Semiconductor Nanotech Lab ECE 598 Quantum Mechanics for Nanotechnology ME 598HJ: Nanomechanics of Electronic Materials ME 598 Manufacturing at the Nanoscale ME 598 SGK Microfactories for Microsystems Manufacturing ME 598 Microtribodynamics **ME 598 Introduction to Nanomechanics**





What is and Why Nanoscale? 100nm ~ 10³ atoms ~10³ structures across one hair Significant surface area • Departure from continuum Unusual 1111120 mechanical/physical properties

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http://www.zyvex.com/nanotech/feynman.html













First Integrated Circuit (An oscillator circuit on germanium substrate)

Jack Kilby,1958, US Patent Application (Texas Instruments)

Nobel prize, 2000

Edward Noyce, 1959, US Patent Application (Fairchild Semiconductor, which later becomes Intel)



By Jack Kilby, Photo courtesy of Texas Instruments, Inc.

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